

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:) Confirmation No.: 1187
Koichiro TANAKA et al.) Examiner: Sang Y. Paik
Serial No.: 10/579,238) Group Art Unit: 3742
Filed: May 12, 2006)
For: LASER IRRADIATION APPARATUS)
AND LASER IRRADIATION METHOD)

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Official Action dated July 19, 2010, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks begin on page 9 of this paper.